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View online: http://dx.doi.org/10.1063/1.4766292
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Evolution of local work function in epitaxial VO$_2$ thin films spanning the metal-insulator transition

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(Received 30 August 2012; accepted 23 October 2012; published online 8 November 2012)

Transport and Kelvin probe force microscopy measurements were simultaneously conducted on epitaxial VO$_2$ thin films. The sample’s work function abruptly dropped from 4.88 eV to 4.70 eV during heating from 333 K to 353 K, suggesting a significant change in its electronic band structure spanning the metal insulator transition. The work function showed nearly no statistical deviation across the film’s surface during the transition, likely due to band bending at the boundaries of the small domains. Resistance profiles confirmed that the local work function corresponded closely to the resistance of the corresponding area. © 2012 American Institute of Physics. [http://dx.doi.org/10.1063/1.4766292]

VO$_2$, a representative correlated electron system, shows a metal-insulator transition (MIT) and a tetragonal-monoclinic structural phase transition (SPT) at around 340 K. The MIT induces significant changes in electrical and optical properties, which could be used in various devices. During the transitions, two distinct electronic and/or structural phases coexist and various experiments with micro- and nano-scopic spatial resolution have been attempted to unveil the mechanism. The nanoscale dichotomy of the MIT and the SPT—the decoupling of the electronic and structural changes—in VO$_2$ thin films has been observed. SPT hysteresis in polycrystalline VO$_2$ thin films has also been reported to be wider than that induced by MIT. Further nanoscopic characterization of VO$_2$’s electronic properties are required to achieve better understanding of its MIT.

Kelvin probe force microscopy (KPFM) can assess the local work function of a sample ($W_{\text{sample}}$), which is determined by its band structure. Maps of $W_{\text{sample}}$ can be used to examine spatial band bending in granular semiconductor thin films. This work reports KPFM observations of the abrupt decrease of VO$_2$ thin films’ local work function during heating above the material’s MIT temperature ($T_{\text{MIT}}$). Statistical deviation of the local $W_{\text{sample}}$ showed little dependence on temperature during the MIT, contrary to the expectation that coexisting metallic and semiconducting phases might lead to variations of local work function across the thin film. Local work function in the small semiconducting domains could be reduced due to band bending by neighboring metallic domains. Modification of carrier concentration should influence the phase transition behavior of the VO$_2$ thin films.

Thin films of VO$_2$ were deposited on Al$_2$O$_3$ (0001) substrates at 550°C by reactive RF magnetron sputtering. The epitaxial films’ multiple domains were confirmed by x-ray diffraction (XRD) and transmission electron microscopy measurements. Samples’ detailed characteristics are reported elsewhere. Planar junctions with 4 $\mu$m wide and 4 $\mu$m gapped Au/Ti electrodes were prepared by conventional photolithography and lift off. Transport characteristics were investigated under an external bias voltage ($V_{\text{ext}}$) applied to the electrodes using a Hewlett-Packard 4156B semiconductor parameter analyzer.

KPFM measurements were conducted using a scanning probe microscopy system (XE-100, Park Systems Co., Korea). Pt-coated Si cantilevers (NSC10/Pt, Micromasch, Estonia) were used in non-contact mode. Sample temperature was controlled by a heating stage. The tip’s work function was calibrated using a highly oriented pyrolytic graphite reference. Topography was measured in AC mode with a drive frequency of 222 kHz (slightly lower than the resonance frequency of the cantilever). Surface potential measurements were simultaneously acquired by applying an AC modulation voltage of amplitude ($V_{\text{ac}}$) 2 V and frequency 20 kHz to the tip. Figure 1 shows a schematic diagram of the transport and KPFM measurements of the VO$_2$ film.

Spatial maps of $W_{\text{sample}}$ were obtained at three different temperatures, as shown in Figure 2(a). Average local work function over 1 $\mu$m$^2$ abruptly dropped from 4.88 to 4.70 eV at 348 K, suggesting a significant change in the electronic structure [Fig. 2(b)]. VO$_2$ has a 3$d^4$ electron system and splitting of the lowest-energy $t_{2g}$ states is known to open a gap at low temperatures. The material’s resistance also sharply decreased at similar temperatures (Fig. 2(b), note the log-scale resistance axis). Based on a percolation model, the resistance of the electronically inhomogeneous system should be explained by the connectivity of metallic domains.

The films were heated at 373 K for 30 min immediately prior to the KPFM measurements to remove possible water adsorbates. The films were then cooled to ~330 K and the KPFM measurements were performed during heating to...
FIG. 1. The VO$_2$ film and the experimental configurations for transport and KPFM measurements.

FIG. 2. (a) $W_{\text{sample}}$ maps obtained at three temperatures during the heating (upper row) and cooling (lower row) of a VO$_2$ thin film (area 1 $\mu$m$^2$), (b) $W_{\text{sample}}$ and resistance curves with respect to temperature, and (c) histograms of $W_{\text{sample}}$ maps at three temperatures during heating.

The sharp drop of $W_{\text{sample}}$ could only be observed after such prior heat treatment, otherwise the samples showed a gradual and slight decrease of $W_{\text{sample}}$ ($\sim$0.05 eV) as the observation temperature increased to 360 K. The samples’ surfaces, exposed to the ambient atmosphere, allowed the adsorption of water, resulting in surface dipoles that hindered observation of the material’s inherent $W_{\text{sample}}$. Recent KPFM observation of vanadium oxide has also shown that near-surface composition can alter the work function change during the transition.

Ultraviolet photoelectron spectroscopy has shown a decrease of $W_{\text{sample}}$ from 4.10 eV to 3.65 eV. This change, 0.45 eV, is much larger than the 0.18 eV observed here by KPFM, despite both methods observing a reduction of $W_{\text{sample}}$ during the MIT. This may be in part due to differences in the measurement conditions: the previous work measured minimum $W_{\text{sample}}$ values using single crystalline nanorods under ultrahigh vacuum; this work recorded average $W_{\text{sample}}$ values of epitaxial thin films in air.

XRD peaks of VO$_2$ thin film have been shown to widen near the transition temperature due to the superposition of two distinct structural phases coexisting during the structural transition. In such an inhomogeneous system, a simple relation for the averaged $W_{\text{sample}}$ can be suggested

$$W_{\text{sample}}(T) = W_{\text{sample,M}} \times [1 - f(T)] + W_{\text{sample,S}} \times f(T),$$

where $f$ is the fraction of semiconducting domains, and $W_{\text{sample,M}}$ and $W_{\text{sample,S}}$, respectively, indicate the work functions of the metallic and semiconducting domains. In the case of VO$_2$ single crystals, $W_{\text{sample,M}}$ and $W_{\text{sample,S}}$ have little dependence of on temperature. Assuming that $W_{\text{sample,M}}$ and $W_{\text{sample,S}}$ have negligible domain-to-domain variation, a bimodal distribution of $W_{\text{sample}}$ would be observed and the full width at half maximum (FWHM) of the distribution would be greatest at the intermediate temperature. However, such is contrary to this work’s KPFM results: the FWHM of histograms of $W_{\text{sample}}$ at three different temperatures ($\sim$0.1 eV) did not vary greatly [Fig. 2(c)].

Figures 3(a) shows schematic energy band diagrams of the metallic (MVO$_2$) and the semiconducting (SVO$_2$) VO$_2$ domains that coexist during the MIT. Local work function in the SVO$_2$ domains decreases, approaching the MVO$_2$-SVO$_2$ domain boundaries due to band bending [Fig. 3(b)]. If the SVO$_2$ domain size is comparable to the width of the space-charge-region (SCR), the local $W_{\text{sample}}$ in those domains is smaller than $W_{\text{sample,S}}$ [Fig. 3(c)] and Eq. (1) loses validity. Instead, the FWHM of $W_{\text{sample}}$ may show little temperature dependence, as per the KPFM results of Fig. 2. Assuming a carrier density ($N$) of $10^{16}$–$10^{18}$ cm$^{-3}$, a relative dielectric ($\varepsilon$) of 30, and built-in potential ($\phi_{\text{bi}}$) of 0.18 eV for VO$_2$ at 60°C, the SCR width, $\sqrt{\frac{2\varepsilon}{\kappa N} (\phi_{\text{bi}} - \frac{q^2}{\kappa})}$, would be 24–240 nm ($q$: electron charge, $\kappa$ the Boltzmann constant, and $T$: temperature). If the SVO$_2$ domains are at least twice size of the SCR width, they would have regions not undergoing band bending. The $W_{\text{sample,S}}$ maps observed here and other nanoscopic domain images show SVO$_2$ domains as small as tens of nm. Therefore, band bending throughout the SVO$_2$ domains is possible in VO$_2$ thin films, leading to a reduction of $W_{\text{sample}}$.

To confirm the relationship between $W_{\text{sample}}$ and resistivity, surface potential maps were recorded under an applied
clear temperature dependence. Greater slopes in the demonstration that KPFM allows observation of local resistivity near 340 K. If the surface composition greatly deviated Therefore, the results in Fig. 5 indicate that the sample did not have a significantly off-stoichiometric surface composi-

cycles in ultrahigh vacuum due to the removal of oxygen. The KPFM results here remained consistent during repeated measurement.

In summary, KPFM was used to observe the sharp drop of epitaxial VO2 thin film’s work function during its MIT, indicating changes in its electronic structure. The thin film’s small domains were shown to undergo band bending adjacent to the domain boundaries, which altered the spatial distribution of carrier concentration and the resulting MIT behavior. Imaging domain distributions in VO2 may aid the design of nanoscale devices that can utilize the large change of dielectric functions during the MIT as well as contribute to the understanding of the underlying phase transition mechanism.

This work was supported by the Quantum Metamaterials Research Center (2009-0063324), the Basic Research Program (2010-0009344), through the National Research Foundation of Korea Grant funded by the Korean Ministry of Education, Science, and Technology (MEST), and a Korea-CIS project of MEST in Korea, and MIT Creative Research Project in ETRI. C.K. and S.R. acknowledge AFOSR Grant No. FA9550-08-1-0203 for financial support.

FIG. 5. (a) Topography and four selected regions (denoted as colored circles) of a VO2 thin film surface and (b) temperature dependence of local Wsample taken at the four regions, external bias voltage (Vext in Fig. 1) of 1 V between the electrodes on the VO2 sample [Fig. 4(b)]. In the subscripts X, V denotes the applied potential: ΔVsurface is defined as [Vsurface,1V − Vsurface,0V], which corresponds to the local potential drop, free of any local variation of Wsample. ΔVsurface profiles show clear temperature dependence. Greater slopes in the ΔVsurface profiles were shown at lower temperature by the semiconducting state; they reduced at higher temperature with the emergence of the metallic state [Figs. 4(b) and 4(c)]. At the intermediate temperature, two distinct regions with different slopes were observed, indicating the coexistence of two electronic phases. Figure 4(c) also shows that the slope of the ΔVsurface profiles varied with changing Wsample. These results demonstrate that KPFM allows observation of local resistivity and the accompanying electronic states of the VO2 thin film.

Spatial variation of local Wsample was also examined: four locations were selected [colored circles in Fig. 5(a)]. Wsample, averaged for each of 50 nm diameter circular areas decreased during heating [Fig. 5(b)]. Vanadium oxides can form several compounds, but only VO2 phase exhibits a MIT near 340 K.6 If the surface composition greatly deviated from VO2 phase, Wsample would not change during the MIT. Therefore, the results in Fig. 5 indicate that the sample did not have a significantly off-stoichiometric surface composition. Yin et al. found that the surface of a VO2 thin film underwent irreversible electronic changes during heating cycles in ultrahigh vacuum due to the removal of oxygen.5